	Application No.	Applicant(s)		
	Application No.			
Notice of Allowability	10/657,429	MIYASAKA, MAMI Art Unit		
Notice of Anovability	Examiner	Art Onit		
	Anthony Quash	2881		
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.				
1. This communication is responsive to an amendment filed on 6/3/04.				
2. The allowed claim(s) is/are 12.				
3. The drawings filed on <u>08 September 2003</u> are accepted by the Examiner.				
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). <ul> <li>a)  All b)</li></ul></li></ul>				
Attachment(s)  1. Notice of References Cited (PTO-892)  2. Notice of Draftperson's Patent Drawing Review (PTO-948)  3. Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview Summary Paper No./Mail Dail 08), 7. Examiner's Amendr	le	·	

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## **DETAILED ACTION**

Applicants' amendment dated 6/3/04 has over come the objections to the specification listed in the last office action dated 3/3/04.

## Allowable Subject Matter

Claim 12 is allowed over the prior art of record.

The following is an examiner's statement of reasons for allowance: The prior art of record does not disclose nor teach the storage device storing the address of a defective first defined mask among the plurality of first masks and the address of a second defined mask having a pattern configuration to used instead of said defective first defined mask, and ... wherein the control device replaces the address of the defective first defined mask with the address of said second defined mask having a pattern configuration to be used instead of said defective first defined mask, in combination with the rest of claim's limitations. Since this aspect is not disclosed nor taught in the prior art of record, independent claim 12 is deemed allowable over the prior art of record.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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## **Conclusion**

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Anthony Quash whose telephone number is (571)-272-2480. The examiner can normally be reached on Monday thru Friday 9 a.m. to 5 p.m..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on (571)-272-2477. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

A. Quash

8/21/04

JOHN R. LEE

SUPERVIZORY PATENT EXAMINER TECHNOLOGY CENTER 2800